

Electronic Patent Application Fee Transmittal

Application Number:	10813829			
Filing Date:	30-Mar-2004			
Title of Invention:	Method of plasma etch endpoint detection using a V-I probe diagnostics			
First Named Inventor/Applicant Name:	Armen Avoyan			
Filer:	Joseph A. Nguyen/Sandra Halliwell			
Attorney Docket Number:	LMRX-P037/P1258			
Filed as Large Entity				
Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Submission- Information Disclosure Stmt	1806	1	180	180
Total in USD (\$)				180